

Substitute Form PTO-1449 (Modified) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 14564-006002	Application No. 10/778,019
		Applicant Garbuzov et al.	
		Filing Date February 13, 2004	Group Art Unit 2828

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
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Foreign Patent Documents or Published Foreign Patent Applications

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							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	Ito, R. and Nakamura, M., Foundation and Application of Semiconductor Laser, BAIFUKAN CO., LTD., 1st Edition, 5th printing, pp. 50-53 and 82-84, March 30, 1995 (Japan), English translation (Japanese language version was previously submitted).
	AR	
	AS	
	AT	

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